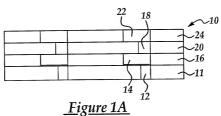
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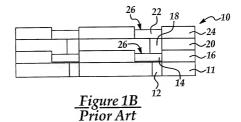
Inventor(s): Shih, et al Serial No.: To Be Assigned Filed: Herewith

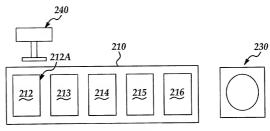
For: Method For Preventing Chemical Attack On A ... Semiconductor Wafer Attorney Docket No.: 67,200-646

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<u>Figure 1A</u> Prior Art





<u>Figure 2</u>

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Filed: Herewith
For: Method For Preventing Chemical Attack On A... Semiconductor Wafer

